APR 1 7 2006 IN THE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop: ISSUE FEE

Hideki KUWAJIMA et al.

Confirmation No. 4682

Serial No. 10/725,627

[Group Art Unit 2652

Filed December 3, 2003

Examiner Jefferson A. Evans

HEAD SUPPORT MECHANISM, AND DISC: RECORDING AND REPRODUCING DEVICE USING THE THIN FILM PIEZOELECTRIC

Attorney Docket No. 2003_1661A

ELEMENT; AND METHOD OF

MANUFACTURING THE THIN FILM

PIEZOELECTRIC ELEMENT

NOTICE RE INCORRECT TITLE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The title indicated in the Notice of Allowance is incorrect. It should read --THIN FILM PIEZOELECTRIC ELEMENT, ACTUATOR, HEAD SUPPORT MECHANISM, AND DISC RECORDING AND REPRODUCING DEVICE USING THE THIN FILM PIEZOELECTRIC ELEMENT; AND METHOD OF MANUFACTURING THE THIN FILM PIEZOELECTRIC ELEMENT---, in accordance with an Amendment to the title on page 2 of the Amendment filed January 6, 2006.

Issuance of the patent with the correct title is respectfully requested.

Respectfully submitted,

Hideki KUWAJIMA et al.

By Charles R. Watts

Registration No. 33,142

Attorney for Applicants

CRW/asd Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 April 17, 2006